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3.20	262	SYNTHESIS OF THE SURFACE ALLOYS AT A HIGH-INTENSITY PULSED ELECTRON BEAM TREATMENT OF THE FILM / SUBSTRATE SYSTEM E. Petrikova, Yu. Ivanov, A. Teresov, O. Krygina
3.21	266	SURFACE TREATMENT OF METALS BY PLASMA OF NON-SELF-MAINTAINED GAS DISCHARGE O.I. Timoshenko, I.O. Misiruk, V.S. Taran, I.E. Garkusha
3.22	270	PULSED PLASMA FLOW INTERACTION WITH DIFFERENT STEEL SURFACES A.M. Zhukeshov, A.T. Gabdullina, A.U. Amrenova, Z. Moldabekov, K. Senik, J. Rysbekova
3.23	274	SURFACE TRANSFORMATION OF METALLIC MATERIALS UNDER EXPOSURE TO HIGH-ENERGY PROCESSES A.G. Anisovich, V. V. Azharonok, V.F. Gologan, V.A. Lyushkevich
3.24	278	ABLATION PROCESSING OF DENTAL TISSUE BY XECL LASER RADIATION BEAM WITH VARIOUS PULSE DURATION S. Anufrik, A. Volodenkov, K. Znosko
3.25	282	OXIDATION OF STEEL SURFACE WITH MICROSTRUCTURES FORMATION DUE TO NANOSECOND PULSED LASER IRRADIATION A.N. Chumakov, I.S. Nikonchuk, B. Gakovic, S. Petrovic, M. Mitric, C. Lupulescu
3.26	286	EXTRACTION OF ELECTRONS FROM PLASMA WITH LIMITED EMISSION ABILITY V.G. Zaleski, P.N. Soldatenko
3.27	290	SPECTROSCOPIC STUDIES OF SHOCK-COMPRESSED PLASMA LAYER FORMED UNDER COMPRESSION PLASMA FLOW ACTION V.M. Astashynski, S.I. Ananin, E.A. Kostyukevich, A.M. Kuzmitski, P.N. Shoronov
3.28	293	MODELING OF DISCHARGE PROCESSES IN THE COMBINED GAS DISCHARGE FACILITY V.V. Astashynski, M.I. Bogach, A.V. Buracheuski, Yu.S. Khadasevich
3.29	297	EFFECT OF He+ ION IRRADIATION ON STRUCTURE AND WEAR RESISTANCE OF TiAIN COATINGS DEPOSITED BY MAGNETRON SPUTTERING S.V. Konstantinov, F.F. Komarov, V.V. Pilko, V.A. Kukareko

VOLUME II

4. NON-IDEAL AND DUSTY PLASMAS

4.02	303	QUASI-2D PHASE TRANSITIONS IN PLASMA-DUST SYSTEMS O.F. Petrov, M.M. Vasiliev, X.G. Koss, K.B. Staisenko, E.V. Vasilieva, E.A. Lisin
4.03	304	CHARGING OF DUST PARTICLES BY ELECTRON BEAMS WITH ENERGY 10-30 keV L.G. Dyachkov, V.M. Chepelev, O.A. Chernukha, O.F. Petrov
4.04	308	OBTAINING OF PARTICLES AND MATERIALS WITH NANOSTRUCTURED SURFACES IN THE COMPLEX PLASMA M.K. Dosbolayev, A.U. Utegenov, T.S. Ramazanov, M.T. Gabdullin, I.I. Filatova
4.05	312	MODIFICATION OF DUST PARTICLES IN PLASMA V.Yu. Karasev, E.S. Dzliteva, V.A. Polischuk, A.P. Gorbenko, S.I. Pavlov, M.M. Makar, M.A. Ermolenko
4.06	316	THE METHOD FOR SYNTHESIS OF SMALL DISPERSE PARTICLES IN COMBINED ARC AND RF DISCHARGES D.G. Batryshev, T.S. Ramazanov, M.K. Dosbolayev, M.T. Gabdullin, Ye. Yerlanuly
4.07	320	PHENOMENA IN COMPLEX (DUSTY) PLASMA STUDIED UNDER MICROGRAVITY CONDITIONS V.I. Molotkov, A.M. Lipaev, D.I. Zhukhovitskii, V.N. Naumkin, V.E. Fortov, O.F. Petrov, S.A. Khrapak
4.08	324	STRUCTURE TRANSFORMATIONS IN CRYOGENIC DUSTY PLASMA B. Antipov, M. Vasiliev, O. Petrov
4.09	327	MODULATION OF DISSIPATIVE DUST-ION ACOUSTIC WAVE IN DUSTY PLASMA H. Alnejad
4.10	331	CHARGING PROCESSES OF THE DUST PARTICLES IN PLASMA TAKING INTO ACCOUNT EMISSION OF ELECTRONS B. Molotkov, V. Savin

OBTAINING OF PARTICLES AND MATERIALS WITH NANOSTRUCTURED SURFACES IN THE COMPLEX PLASMA

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Introduction

The presence of dust particles in the plasma volume has found a positive approach in many technological applications. One of them is the use of dusty plasma in the production of high-tech composite materials such as small spherical particles with nanocoatings deposited in the plasma. For example, co-deposition of silicon particles in nanometer scale can lead to a significant improvement in stability of solar cells [1].

Classical magnetron method and cluster beams in magnetron discharge are often used for the coating deposition on the surface of dust particles. The conditions in which a thin layer of metal deposited on dust particles surface by interaction with plasma has been described in [2-7]. In these experiments plasma of high frequency discharge was used to hold the dielectric particles that are formed a stable and ordered structures. Resulting in sputtering of the cathode at the magnetron discharge, the atoms of metal adhered to the particles and formed a thin film on a surface of dielectric particles.

In this paper, we report on the production of composite materials in the dusty plasma using the magnetron sputtering method. The main advantage of this method is the weak heat flux on the surface of the deposited material and a wide range of materials which can be used for the deposition.

Experimental setup

A schematic diagram of the experimental setup is shown in Figure 1. Hollow glass microspheres with known properties and chemical composition (SiO₂, CaO, O, Na₂O, Al) were used for nanolayer coating deposition in complex plasma.

The process of deposition is as follows: the electrodes are supplied by high-frequency voltage with a frequency of 13.56 MHz, thereby the plasma of high-frequency gas discharge is ignited in the interelectrode space. Then dust particles were injected into the plasma. The experimental parameters were as

follows: $p=0.15$ Torr, $P=5$ W – for RF discharge and $U=235$ B, $f=0.22$ A – for magnetron discharge.

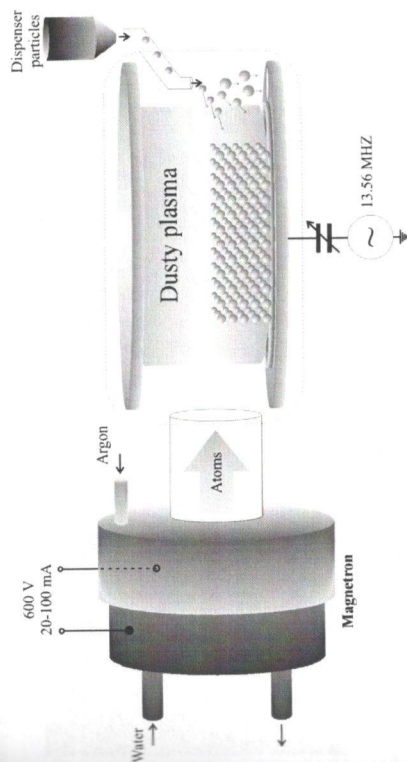


Fig. 1. The schematic diagram of experimental setup

As it is known that particles form in a plasma environment different dusty structures (cloud) due to the balance of the two forces (gravitational and electrostatic) [8-10]. Further, for the coating formation on the surface of dust particles the atomic beam produced by a magnetron is forwarded. Thus, we obtained in plasma created by the combination of high-frequency and magnetron discharges particles coated with the cathode material of the magnetron.

Experimental results

Surface properties of the obtained laboratory samples were tested by scanning electron microscope Quanta 3D 200i (SEM, USA FEI company). After synthesis, the dust particles levitated in RF plasma were withdrawn into a container by the trap located on the lower electrode. Then a conductive tape was loaded into the scanning microscope.

It was revealed from the SEM study (Figure 2) that the chemical composition of the synthesized material, except to the chemical elements corresponded to the original composition of the microparticles, consisted of atomic peaks corresponded to the sprayed material – copper (Figure 3). The thickness of the nanolayer on the particle surface was evaluated as 50 – 200 nm. The the nanolayer thickness formed on the particle depended on the exposure time, the more time, the thicker the coating.

Also, The figures shown that the nanocoating distributed uniformly over the surface of the investigated particles, indicating that the deposition of glass microparticles occurred in levitating conditions (Figure 3).

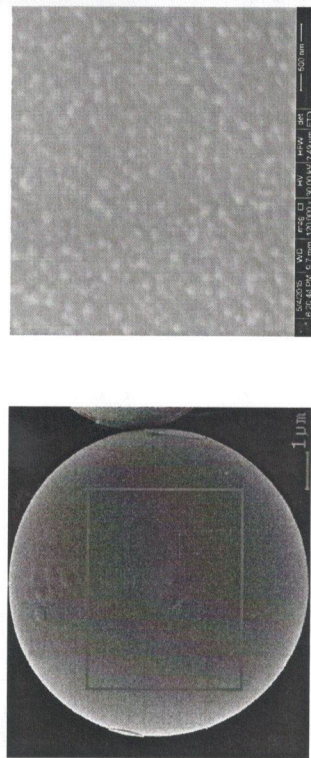


Fig. 2. SEM image of a copper coated hollow glass microsphere

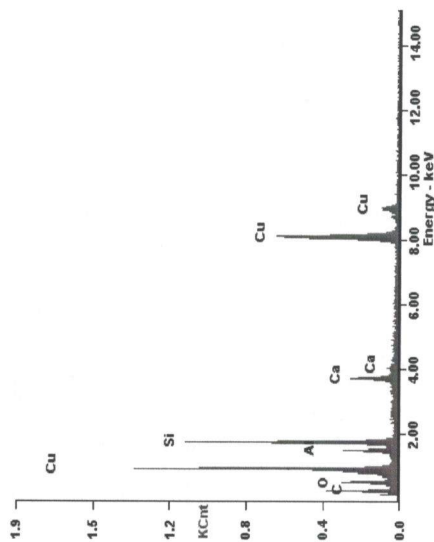


Fig. 3. The chemical composition of the synthesized material coated microparticle (a sample of particle coated with copper)

Thus, by the use of collected experimental setup the nanostructured materials were obtained, i.e. glass microparticles with copper nanolayer; the characteristics and properties of the composite materials were analyzed.

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